



Attorney Docket No. 0756-2409

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/021,719

Filed: December 19, 2001

For: LASER ANNEALING METHOD AND

SEMICONDUCTOR DEVICE

FABRICATING METHOD

) Group Art Unit: 2818

) Examiner: D. Le

) CERTIFICATE OF MAILING  
I hereby certify that this correspondence is  
being deposited with the United States Postal  
Service with sufficient postage as First Class  
Mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450, on August 29,  
2005

) Adam M. Stampen

REVISED SUPPLEMENTAL AMENDMENT

*Please enter this paper  
into the file 11/14/05*  
Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the  
above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on  
page 2 of this paper.

**Remarks** begin on page 13 of this paper.